

U.S. Patent Application No. 10/518,704
Response to Office Action mailed May 18, 2007**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants : Tetsuo YAMADA, et al.

Serial No. : 10/518,704

For : THIN FILM PIEZOELECTRIC RESONATOR, THIN FILM PIEZOELECTRIC DEVICE, AND MANUFACTURING METHOD THEREOF (As Amended)

Filing Date : December 17, 2004

Examiner : Mark Osborne Budd

Group Art Unit : 2834

Confirmation No. : 5674

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I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on June 14, 2007.

Ronald R. Sautter, Reg. No. 28,988

(Name of Applicant, Assignor or Registered Representative)

Signature

June 14, 2007

Date of Signature

AMENDMENT

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action dated May 18, 2007, setting a two-month period for response ending July 18, 2007, Applicants respectfully request that the application be further amended as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks begin on page 17 of this paper.